



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA et al.

Application No.: 09/769,832

Filed: January 26, 2001

For: PROJECTION EXPOSURE APPARATUS AND METHOD, CATADIOPTRIC
OPTICAL SYSTEM AND MANUFACTURING METHOD OF DEVICES

Group Art Unit: 2851

Examiner: R. Fuller

Docket No.: 108455

#13 / C-13 / B
D. EVANS
6-11-03

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the December 18, 2002 Office Action, the shortened statutory period for
reply being extended by the attached Petition for Extension of Time, the following is
submitted:

Amendments to the Claims are reflected in the listing of claims; and

Remarks.

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MAY 27 2003
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